

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE CROUP 1003

In re Patent application of

Jae-dong Lee et al.

Serial No. 10/023,948

Examiner Lynette T. Umez-Eronini

Filed December 21, 2001

CHEMICAL MECHANICAL POLISHING SLURRY

AMENDMENT

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, Mail Stop Non-Fee Amendment Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Sir:

In response to the Office action of May 7, 2003, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.